INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 19, 2026	
IGI Report Number	LG849655019
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	7.27 X 7.10 X 5.18 MM

GRADING RESULTS

Carat Weight	2.39 CARATS
Color Grade	E
Clarity Grade	VS 1

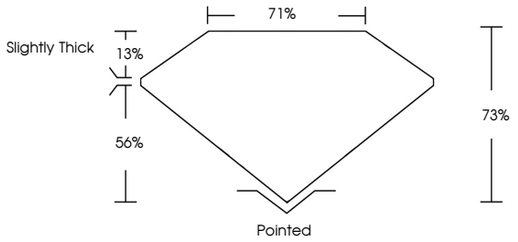
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG849655019

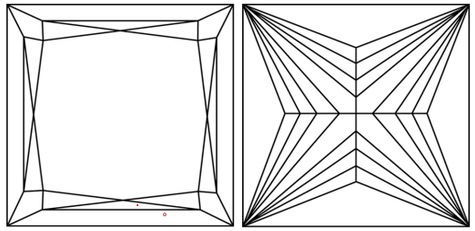
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG849655019
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

www.igi.org



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

© IGI 2020, International Gemological Institute

FD - 10 20

THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

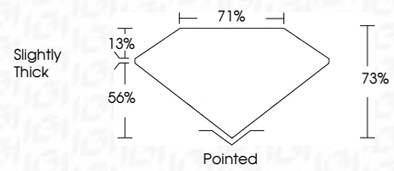
LABORATORY GROWN DIAMOND REPORT

October 19, 2026

IGI Report Number	LG849655019
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	7.27 X 7.10 X 5.18 MM

GRADING RESULTS

Carat Weight	2.39 CARATS
Color Grade	E
Clarity Grade	VS 1



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG849655019

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI

October 19, 2026
IGI Report No LG849655019
PRINCESS CUT
7.27 X 7.10 X 5.18 MM
2.39 CARATS
E
VS 1
73%
71%
Slightly Thick
Pointed
EXCELLENT
EXCELLENT
NONE
IGI LG849655019
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa